IFW



PATENT Customer No. 22,852 Attorney Docket No. 03180.0273-02000

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:		
Shinichi ITO et al.		

Group Art Unit: 1746

Application No.: 10/775,251

Examiner: Kornakov, M.

Filed: February 11, 2004

Confirmation No.: 1100

For:

CHEMICAL LIQUID PROCESSING APPARATUS FOR PROCESSING A SUBSTRATE AND THE METHOD

**THEREOF** 

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## RESPONSE TO RESTRICTION REQUIREMENT

In a restriction requirement mailed September 21, 2005, the Examiner required restriction under 35 U.S.C. § 121 between Group I, claims 1 and 24-32, and Group II, claims 2 and 33-41. Applicants provisionally elect to prosecute Group II, claims 2 and 33-41 drawn to a chemical liquid processing apparatus classified in class 134, subclass 137.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,

GARRETT & DUNNER, L.L.P.

Dated: October 21, 2005

Richard V. Burgujian

Reg. No. 31,744